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PATENT 8074-1143

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Koichi NANIWAE

Conf.

Application No. NEW NATIONAL PHASE

Group

Filed March 24, 2006

Examiner

METHOD OF CLEANING TREATMENT AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

March 24, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begin on page 3 of this paper.

Remarks begin on page 17 of this paper.

An $\mbox{\bf Appendix}$ is attached following the signature page of this paper.